



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Ting Chien et al.

Application No.: 09/820,692

Filing Date: March 30, 2001

Title: PLASMA ETCHING OF DIELECTRIC LAYER WITH SELECTIVITY TO STOP LAYER

Group Art Unit: 1765

Examiner: KIN CHAN CHEN

Confirmation No.: 5245

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following extension of time is requested to: extend the time for responding to the Final Official
Action dated December 14, 2005

one month to April 14, 2005 ☐ \$60.00 (2251) ☒ \$120.00 (1251)

☐ The shortened statutory period has been reset by an Advisory Action dated _____.

☐ An extension fee in the amount of _____ is enclosed.

☒ Charge \$ 120.00 to Deposit Account No. 02-4800.

☐ Charge _____ to credit card. Form PTO-2038 is attached.

The Director is hereby authorized to charge any appropriate fees under 37 C.F.R. §§1.16, 1.17 and
1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800.
This paper is submitted in duplicate.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

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02 FC:1251 120.00 DA

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Date: April 14, 2005

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